\ \		
	Application No.	Applicant(s)
A	10/623,786	NAKAJIMA ET AL.
Notice of Allowability	Examiner	Art Unit
	Gwendolyn A. Blackwell-Rudasill	1775
The MAILING DATE of this communication appearance All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIOF the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this apport or other appropriate communication IGHTS. This application is subject to	plication. If not included will be mailed in due course. THIS
1. This communication is responsive to 28 May 2004.		
2. 🔀 The allowed claim(s) is/are <u>5-7</u> .		
3. A The drawings filed on 21 July 2003 are accepted by the Ex	aminer.	
4. Acknowledgment is made of a claim for foreign priority ur a) All b) Some* c) None of the:		
 Certified copies of the priority documents have Certified copies of the priority documents have 		9/066 215
3. ☐ Copies of the certified copies of the priority documents have		
International Bureau (PCT Rule 17.2(a)).	cuments have been received in this	national stage application from the
* Certified copies not received:		
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		complying with the requirements
5. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give		
6. CORRECTED DRAWINGS (as "replacement sheets") mus	et be submitted.	
(a) including changes required by the Notice of Draftspers	on's Patent Drawing Review (PTO-	948) attached
1) 🗌 hereto or 2) 📗 to Paper No./Mail Date		
(b) including changes required by the attached Examiner's Paper No./Mail Date	s Amendment / Comment or in the C	Office action of
Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in the		
 DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT 		
Attachment(s)	5 Motion of Informal P	atent Application (PTO-152)
 Notice of References Cited (PTO-892) D Notice of Draftperson's Patent Drawing Review (PTO-948) 	6. ☐ Interview Summary	, , ,
3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SB/0	Paper No./Mail Dat	te
Paper No./Mail Date	9 ⊠ Evaminada Statama	ent of Reasons for Allowance
Examiner's Comment Regarding Requirement for Deposit of Biological Material	9. Other	Steph St. 3
		STEPHEN STEIN RIMARY EXAMINER

DETAILED ACTION

Specification

1. The abstract of the disclosure is objected to because the length of the abstract is too long. The abstract has been amended by Examiner's Amendment as set forth below to meet the length requirements of the abstract. *MPEP608.01(b)*.

EXAMINER'S AMENDMENT

- 2. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.
- 3. The application has been amended as follows:
- 4. In the specification, line 1, after the title insert -- This application is a division of U.S. Serial No. 09/966,215 filed September 28, 2001, abandoned.--
- 5. Delete the abstract and insert A silica layer is provided which is usable as a low refractive index layer undergoing no change in its refractive index. Further, a silica layer is provided which is highly productive and usable as a medium or high refractive index layer undergoing neither reduction in transmittance nor change in spectral colors. Still further, an antireflection film using these silica layers is provided.--

Allowable Subject Matter

6. Claims 5-7 are allowed over the prior art of record.

7. The following is an examiner's statement of reasons for allowance:

The prior art while teaching that SiO_xC_y can be used as a layer on a substrate as an antireflective film having a refractive index as exemplified by Applicant, it does not teach or suggest the compositional limitations of the $SiO_{x/a/d}C_{y/b/e}$ in relation to the x/a/d and y/b/e subscripts for the oxygen and carbon components, respectively, of the silicon oxynitride film in conjunction with a particular refractive index. The prior art of record also does not teach or suggest the silicon oxynitride layer structure as claimed by Applicant.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Gwendolyn A. Blackwell-Rudasill whose telephone number is (571) 272-1533. The examiner can normally be reached on Monday - Thursday; 6:00 am - 4:30 pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Deborah Jones can be reached on (571) 272-1535. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Art Unit: 1775

Information regarding the status of an application may be obtained from the Patent

Application Information Retrieval (PAIR) system. Status information for published applications

may be obtained from either Private PAIR or Public PAIR. Status information for unpublished

applications is available through Private PAIR only. For more information about the PAIR

system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR

system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Gwendolyn A. Blackwell-Rudasill

Examiner

Art Unit 1775

PRIMARY EXAMINER

Steph Sten-